

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Daisuke KOMADA, et al.

Serial No.: 10/058,426

Filed: January 30, 2002

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE HAVING
SILICON CARBIDE FILM**



Group Art Unit: 1756

Examiner: BARRECA, Nicole M.

Confirmation No.: 4298

Attorney Docket No.: 020060

Customer Number: 38834

RESPONSE UNDER 37 C.F.R. § 1.116

- EXPEDITED RESPONSE -

Mailstop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

July 20, 2004

Sir:

In response to the Office Action dated April 1, 2004, Applicant amends the claims as follows and submits the following remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.

Do
not
enter
8/9/04
ny